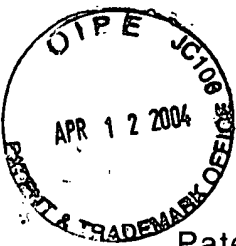


04-14-04

2812



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. ....10/607,869  
Filing Date .....June 27, 2003  
Inventorship .....Zhongze Wang  
Assignee .....Micron Technology, Inc.  
Group Art Unit .....2812  
Examiner .....Jennifer M. Kennedy  
Attorney's Docket No. ....MI22-2343  
Title: Method of Forming Silicon-on-Insulator Comprising Integrated  
Circuitry

**RESPONSE TO MARCH 18, 2004 OFFICE ACTION**

To: Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**VIA EXPRESS MAIL**

From: Mark S. Matkin (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 West First Avenue, Suite 1300  
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Responsive to the Office Action dated March 18, 2004, Applicant  
amends and remarks as follows:

**AMENDMENTS**